

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

IWAMATSU, SEIICHI

Examiner

David A Vanore

Art Unit

2881

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
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